

Notice of References Cited	Application/Control No. 10/669,178	Applicant(s)/Patent Under Reexamination AVAZI ET AL.	
	Examiner Dean O. Takaoka	Art Unit 2817	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,894,586	05-2005	Bircumshaw et al.	333/133
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Pourkamali, Electrically Coupled MEMS Bandpass Filters, April 2004, Georgia School of Technology, 83 pages
	V	De Los Santos, MEMS For RF/Microwave Wireless Applications: The Next Wave - Part II, July 2001, Microwave Journal, 6 pages
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.